

4 of 1
Sheet 2 of 2

Substitute Form PTO-1449 (Modified)	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 05542-552001	Application No. 10/732,966
Information Disclosure Statement by Applicant (Use several sheets if necessary) (37 CFR §1.98(b))		Applicant Chen et al.	
		Filing Date December 10, 2003	Group Art Unit Unknown

Foreign Patent Documents or Published Foreign Patent Applications							
Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation Yes No
dy	AY	2 336 121 A	10/13/99	Great Britain			

Other Documents (Include Author, Title, Date, and Place of Publication)		
Examiner Initial	Desig. ID	Document
dy	AZ	"SPM's PPS Ring Sales History", January 1997 thru November 1999
dy	AAA	Yuan, et al., A novel Wafer Carrier Ring Design Minimizes Edge Over-Polishing Effects for Chemical Mechanical Polishing, June 27-29 1995 VMIC Conference, 1995 JSMIC 104/95/525, pp. 525-527.

Examiner Signature <i>Chen et al.</i>	Date Considered 5/29/06
EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	

Substitute Disclosure Form (PTO-1449)